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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Kangguo CHENG et al.

Group Art Unit: 2891

Appln. No.

: 10/710,608

Examiner: Reames, M.

Filed

: July 23, 2004

Confirmation No.: 4607

For

: PATTERNED STRAINED SEMICONDUCTOR SUBSTRATE AND

DEVICE

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop <u>Amendment</u>
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated November 16, 2006, please amend the aboveidentified application as follows.

A listing of claims begins on page 2.

Remarks begin on page 9.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.